



66 -- Nanoscience Chlorine Inductively Coupled Plasma RIE System

- [Combine Synopsis/Solicitation](#) - Posted on Feb 23, 2005
- [Amendment to Combined Synopsis/Solicitation 01](#) - Posted on Feb 23, 2005

General Information

Document Type: Amendment to Combined Synopsis/Solicitation
Solicitation Number: N00173-05-R-HA01
Posted Date: Feb 23, 2005
Original Response Date: Mar 31, 2005
Current Response Date: Mar 31, 2005
Original Archive Date: Apr 15, 2005
Current Archive Date: Apr 15, 2005
Classification Code: 66 -- Instruments & laboratory equipment
Naics Code: 333295 -- Semiconductor Machinery Manufacturing

Contracting Office Address

Department of the Navy, Office of Naval Research, Naval Research Laboratory, 4555 Overlook Ave.
S.W., Washington, DC, 20375

Description

The purpose of this Amendment 0002 is to correct the link by which the Specifications of the combined synopsis/RFP is located. The correct website address is as follows:
<http://heron.nrl.navy.mil/contracts/RFP/05ha01.htm>

Point of Contact

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Place of Performance

Address: Naval Research Laboratory Washington, DC 20375
Postal Code: 20375
Country: USA

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